

Form PTO-1449 U.S. DEPARTMENT OF COMMERCE (REV.7-80) PATENT AND TRADEMARK OFFICE										Atty. Docket No. GB 010071		Serial No.	
INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)										Applicant Pieter J. Van der ZAAG et al.			
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U.S. PATENT DOCUMENTS														
Ex. Int.		Document Number								Date	Name	Class	Sub-class	Filing Date If Approp.
	AA	5	1	3	0	8	2	9	7/14/92	Shannon	359	59		
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FOREIGN PATENT DOCUMENTS															
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														Yes	No
	AG														
	AH														
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OTHER (Including Author, Title, Date, Pertinent Pages, Etc.)													
	AL	"Excimer-Laser-Produced Amorphous Silicon Vertical thin Film Transistors' by A. Saitoh et al, Jpn. J. Appl. Phys. Vol. 36 (1997) pp. 668-9											
	AM	"IBM Technical Disclosure Bulletin, Vol. 29 No. 5, Oct 1986, pp. 2224-6											
	AN												

Examiner	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.

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Examiner <i>DBH</i>										Date Considered 1/08/03					
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Notice of References Cited	Application/Control No. 10/142,587	Applicant(s)/Patent Under Reexamination VAN DER ZAAG ET AL.	
	Examiner David S Blum	Art Unit 2813	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-US006461901B1	10-2002	Noguchi	438/158
	B	US-US006414164B1	07-2002	Afzali-Ardakani et al	549/59
	C	US-US006504175B1	01-2003	Mei et al	257/66
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	Q					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
	U	Stanley Wolf SILICON PROCESSING for the VSLI ERA Vol. 1 Lattice Press 1986 pages 452,468-471,480,501-502				
	V	John L. Vossen THIN FILM PROCESSES II Academic Press 1991 pages 34-35				
	W					
	X					

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.